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Confirmation Letter

To.

VINAY KUMAR SINGH

Published in : Volume 4 | Issue 11 | 2017-11-01



Subject: Publication of paper at International Journal of Emerging Technologies and Innovative Research.

Dear Author,

With Greetings we are informing you that your paper has been successfully published in the International Journal of Emerging Technologies and Innovative Research (ISSN: 2349-5162). Following are the details regarding the published paper.

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